

Image



2827
\$

Examiner : Alonzo Chambliss
Art Unit : 2827
Docket No.: 52433/609

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : K. TATSUMI et al.
Serial No. : 09/632,910
Filed : August 4, 2000
For : METHOD FOR FABRICATING A SEMICONDUCTOR DEVICE PROVIDED WITH
LOW MELTING POINT METAL BUMPS

Commissioner for Patents
P.O. Box. 1450
Alexandria, VA 22313-1450

TRANSMITTAL LETTER

SIR:

Transmitted herewith is an Amendment/Response in the
above-identified patent application.

[X] No additional fee is required.

The fee has been calculated as shown below.

SMALL ENTITY						OTHER THAN A SMALL ENTITY	
CLAIMS REMAINING AFTER AMENDMENT	HIGHEST NO. PREVIOUSLY PRESENT PAID FOR		RATE	ADDIT. OR FEE	RATE	ADDIT. FEE	
TOTAL 8 MINUS 20 = 0			x9 =	\$	x18 =	\$ 0.00	
INDEP. 2 MINUS 4 = 0			x40 =	\$	x86 =	\$ 0.00	
[] FIRST PRESENTATION OF MULTIPLE			x135 =	\$	x290 =	\$ 0.00	
DEP. CLAIM			TOTAL				
			ADDIT. FEE	\$	OR	\$ 0.00	

[X] The Commissioner is hereby authorized to charge fees under 37 CFR
1.16 and 1.17 which may be required to Deposit Account 11-0600. A
duplicate of this paper is enclosed.

[X] A petition for a three (3) month extension of time and Deposit
Account authorization to cover the extension fee are enclosed.

[] Priority Document.

I hereby certify that this correspondence is being deposited with
the United States Postal Service as First Class Mail in an
envelope addressed to: Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450, on November 20, 2003

John J. Kelly, Jr.
John J. Kelly, Jr. Reg. No. 29,182

Respectfully submitted,
KENYON & KENYON

By: John J. Kelly, Jr.
John J. Kelly, Jr.
Reg. No. 29,182



I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on November 20, 2003.

John J. Kelly, Jr.

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AMENDMENT

SIR:

Reconsideration of the above-identified patent application, as amended, is respectfully requested. The present amendment is responsive to the Office Action mailed May 21, 2003. A petition for an extension of time in which to respond to the Office Action accompanies this amendment.